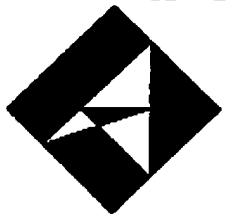


**A T M I**

7 Commerce Drive, Danbury, CT 06810 203.794.1100 203.797.2544  
web.atmi.com info@atmi.com

## facsimile transmittance

To: Examiner Erik J. Kielin Fax: 703-872-9319  
From: Mag Chappuis Date: June 19, 2003  
E-mail: [Mchappuis@atmi.com](mailto:Mchappuis@atmi.com) Pages: 30  
Re: Response to Final Office Action in cc:  
United States Patent Application No.  
09/823,196

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### RESPONSE TO MARCH 27, 2003 FINAL OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 09/823,196

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Dear Examiner Kielin:

Please find the following documents enclosed:

Response to March 27, 2003 OA – 13 sheets  
Appendix A including cover – 10 sheets  
Appendix B including cover – 4 sheets  
Appendix C including cover – 2 sheets  
Transmittal – 1 sheet

Please call 203-794-1100 ext. 4184 if there are any problems with this transmittal.

Maggie Chappuis

ATMI, Inc.  
7 Commerce Drive  
Danbury, CT 06810  
203-794-1100 (telephone)  
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ATMI Docket: ATM-510

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U.S. Patent Application No. 09/823,196

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**#15/B  
Am 2d  
N/E**In re United States Patent Application of:****Applicants:** Thomas H. Baum et al.**Serial No.:** 09/823,196**Date Filed:** March 30, 2001**Title:** SOURCE REAGENT COMPOSITIONS  
FOR CVD FORMATION OF GATE  
DIELECTRIC THIN FILMS USING  
AMIDE PRECURSORS AND METHOD  
OF USING SAME**Docket No.:** ATMI-510**Examiner:** Erik J. Kielin**Art Unit:** 2813**Customer No.:** 25559J. McMillan  
7/12/03**FACSIMILE TRANSMISSION CERTIFICATE**

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*Maggie Chappins*  
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**RESPONSE TO MARCH 27, 2003 FINAL OFFICE ACTION IN UNITED STATES  
PATENT APPLICATION NO. 09/823,196**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 27, 2003, applicant respectfully requests entry of the following Amendments and consideration of the subsequent remarks.

DO NOT ENTER 7/14/03 ER